

Notice of References Cited

Application/Control No.

09/533,762

Applicant(s)/Patent Under
Reexamination
LEE ET AL.

Examiner

Peng Ke

Art Unit

2174

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,181,335	01-2001	Hendricks et al.	345/723
*	B	US-5,835,094	11-1998	Ermel et al.	345/419
*	C	US-6,154,750	11-2000	Roberge et al.	345/854
*	D	US-6,133,911	10-2000	Kim, Pil Tae	345/719
*	E	US-5,425,140	06-1995	Bloomfield et al.	345/841
	F	US-5,914,717	06-1999	Kleewein et al.	345/843
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 1206424 A	08-1989	JP	Tanobe et al	
*	O	JP 4246720 A	09-1992	JP	Tsugou et al	
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.